



Appl. No. 09/648,111

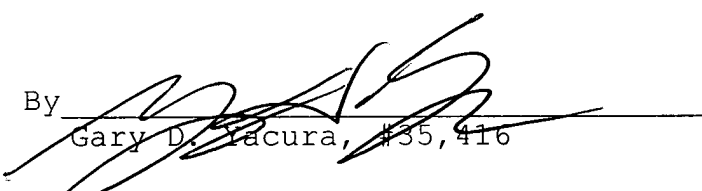
- ☒ Petition for one (1) month(s) extension of time pursuant to 37 C.F.R. §§ 1.17 and 1.136(a). \$110.00 for the extension of time.
- ☐ No fee is required.
- ☒ A check in the amount of \$110.00 is enclosed.
- ☐ Please charge Deposit Account No. 02-2448 in the amount of \$0.00. This form is submitted in triplicate.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 02-2448 for any additional fees required under 37 C.F.R. § 1.16 or under 37 C.F.R. § 1.17; particularly, extension of time fees.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

By

  
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GDY/PLS:sld  
3430-0131P

ATTACHMENT

(Rev. 01/22/01)



PATENT  
3430-0131P

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT(S): HWANG, Kwang-Jo

SERIAL NO.: 09/648,111

GROUP: 2815

FILED: August 25, 2000

EXAMINER: Brock II, P.

FOR: METHOD OF PATTERNING A METAL LAYER IN A  
SEMICONDUCTOR DEVICE

RECEIVED  
AUG 23 2001  
TECHNOLOGY CENTER 2800  
1. flowers

### *RULE 111 AMENDMENT*

Assistant Commissioner for Patents  
Washington, D.C. 20231

August 23, 2001

Dear Sir:

In response to the Office Action dated April 24, 2001, the following amendments and remarks are respectfully submitted under 37 C.F.R. §1.111 in connection with the above-identified application.

### *IN THE CLAIMS:*

Please amend claims 1, 12 and 22 as follows:

1. A method of manufacturing a liquid crystal display device, comprising:  
forming a switching element on a substrate;  
forming a passivation layer over the substrate;  
depositing a metal layer on the passivation layer;

A1